

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
Deok-kee Kim et al. Conf. No.: 4565  
Serial No.: 10/710,566 Group Art Unit: 2811  
Filed: July 21, 2004 Examiner: A. Arena  
For: TOP-OXIDE-EARLY PROCESS AND ARRAY TOP OXIDE  
PLANARIZATION

Commissioner for Patents  
United States Patent and Trademark Office  
P. O. Box 1450  
Alexandria, Virginia 22313-1450

REQUEST FOR RECONSIDERATION UNDER 37 C. F. R. §1.116

Sir:

In response to the Office Action mailed April 3, 2007, please reconsider the above-identified application in view of the following remarks.

No amendments to the specification are presented in this paper.

A full listing of the claims begins on page 2 of this paper.

Remarks begin on page 7 of this paper.